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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Robert A. Bellman et al.

Serial No: 10/722,769

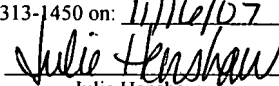
Group Art Unit: 1765

Filing Date: November 26, 2003

Examiner: Kin-Chan Chen

Title: METHOD USING MULTI-COMPONENT COLLOIDAL ABRASIVES FOR
CMP PROCESSING OF SEMICONDUCTOR AND OPTICAL MATERIALS

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

<p>CERTIFICATE OF MAILING (37 CFR 1.8a)</p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: <u>11/16/07</u></p> <p> Julie Henshaw</p>

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In reply to the Notice of Non-Compliant Amendment mailed November 13, 2007, in the above-referenced application, please enter the following amendments and the accompanying remarks.

If any additional fees for the accompanying response are required, Applicants respectfully request that this be considered a petition therefor. Applicants hereby authorize the Office to charge any necessary fees or surcharge that may be required to Deposit Account 03-3325.

Amendments to the Claims are reflected in the Listing of Claims that begins on page 2 of this paper; and

Remarks begin on page 7 of this paper.